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REMARKS

Entry of this Amendment is proper since it narrows the issues on appeal ar require further search by the Examiner.

Claims 15-27 and 56-75 are all the claims presently pending in the applica 15, 20-21, 26-27 and 74-75 have been amended to more clearly define the claims

It is noted that the claim amendments herein are made only for more particular out the invention, and not for distinguishing the invention over the prior art, narroclaims, or for any statutory requirements of patentability.

Further, it is noted that, notwithstanding any claim amendments made he Applicant's intent is to encompass equivalents of all claim elements, even if ame later during prosecution.

Claims 15-16, 19-20, 27, 56, 60, 62, 65, 67 and 75 stand rejected under 3 102(b) as being anticipated by Guenzer (U.S. Patent No. 5,478,653). Claims 15, stand rejected under 35 U.S.C. § 102(e) as being anticipated by Wilk et al. (U.S. 6,248,621). Claims 17-18 and 57 stand rejected under 35 U.S.C. § 103(a) as being over Guenzer in view of Setsune et al. (U.S. Patent No. 4,980,339). Claims 68 a rejected under 35 U.S.C. § 103(a) as being unpatentable over Guenzer in view of (U.S. Patent No. 6,096,434). Claims 71 and 73 stand rejected under 35 U.S.C. § unpatentable over Guenzer in view of Ami et al. (U.S. Patent No. 6,610,548). Cl 26, 61, 66 and 63-64 stand rejected under 35 U.S.C. § 103(a) as being unpatental in view of Reisman et al. (U.S. Patent No. 4,891,329). Claim 69 stands rejected § 103(a) as being unpatentable over Guenzer in view of Reisman et al. and furth Yano.

These rejections are respectfully traversed in view of the following discu

I. THE CLAIMED INVENTION

Applicant's invention, as disclosed and claimed (e.g., see independent cla

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directed to a semiconductor structure which includes a substrate, a crystalline oxid including single-crystal oxide formed over the substrate, and an epitaxial silicon is the crystalline oxide layer.

In another aspect (e.g., as defined in claim 21), a semiconductor structure substrate, a crystalline oxide layer including single-crystal oxide formed over the an epitaxial germanium layer formed on the crystalline oxide layer.

In a third aspect (e.g., as defined in claim 27), a semiconductor structure is crystalline oxide surface including a single-crystal oxide surface, and an amorpho least one of silicon, germanium, gallium arsenide, aluminum arsenide, indium phaluminum antimonide, indium arsenide, gallium phosphide and mixed alloys ther on the crystalline oxide surface by evaporation or chemical vapor deposition.

Conventional semiconductor structures include layers (e.g., epitaxial silic formed on oxide layers which are not single-crystal oxide. Such structures, there form a structure in which the layers are lattice-matched, substantially defect-free (Application at page 3, lines 14-24).

The claimed invention, on the other hand, includes a layer (e.g., epitaxial epitaxial germanium, or an amorphous layer) formed on a crystalline oxide layer single-crystal oxide (Application at page 8, line 2-page 9, line 16). This allows t invention to form a structure in which the layers are lattice-matched, substantiall uniform (Application at page 9, lines 9-16).

II. THE 35 USC 112, FIRST PARAGRAPH REJECTION

The Examiner alleges that claims 74-75 are not enabled by the specificat note, however, that these claims have been amended to address the Examiner's of

Specifically, claim 74 (and similarly claim 75) has been amended to recicrystalline oxide layer is <u>perfectly</u> lattice-matched to silicon", which is clearly d present Application at page 8, lines 21-24.

Therefore, the Examiner is respectfully requested to withdraw this reject

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III. THE PRIOR ART REFERENCES

A. The Guenzer Reference

The Examiner alleges that Guenzer teaches the invention of claims 15-16, 60, 62, 65, 67 and 75. Applicant submits, however, that there are elements of the invention that are not taught or suggested by Guenzer.

Guenzer discloses a bismuth titanate (BTO) layer allegedly used as a temp growth of crystallographically-oriented silicon. Specifically, Guenzer discloses a layer of BTO which is polycrystalline (Guenzer at col. 1, lines 50-57).

However, Guenzer does not teach or suggest "a crystalline oxide layer cocrystal oxide formed over said substrate", as recited in claim 15 and similarly rec 21 and 27.

As noted above, unlike conventional semiconductor structures which do relayers (e.g., epitaxial silicon layers) formed on oxide layers which are single-crystic claimed invention includes a layer, such as epitaxial silicon, epitaxial germanium amorphous layer, formed on a crystalline oxide layer which includes single-crystic (Application at page 8, line 2-page 9, line 16). This allows the claimed invention structure in which the layers are lattice-matched, substantially defect-free and un (Application at page 9, lines 9-16).

Clearly, these novel features are not taught or suggested by Guenzer. Ind Examiner expressly concedes that this is not taught or suggested by Guenzer at r of the Office Action.

Therefore, Applicant respectfully submits that Guenzer does not teach or and every element of the claimed invention. Therefore, the Examiner is respect withdraw this rejection.

B. The Wilk et al. Reference

The Examiner alleges that Wilk teaches the invention of claims 15, 60, 6
Applicant submits, however, that there are elements of the claimed invention the

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or suggested by Wilk.

Wilk discloses a crystalline silicon layer formed on a perovskite barrier la Abstract).

However, Wilk, like Guenzer, does not teach or suggest "a crystalline oxicomprising single-crystal oxide formed over said substrate", as recited in claim 1 recited in claims 21 and 27.

As noted above, unlike conventional semiconductor structures, the claime includes a layer, such as epitaxial silicon, epitaxial germanium, or an amorphous on a crystalline oxide layer which includes single-crystal oxide (Application at papage 9, line 16). This allows the claimed invention to form a structure in which to lattice-matched, substantially defect-free and uniform (Application at page 9, line

Clearly, these novel features are not taught or suggested by Wilk. Indeed the Examiner even allege that this feature is taught or suggested by Wilk.

In fact, the Examiner attempts to equate the barium strontium oxide layer calcium strontium titinate layer 5 in Wilk with the crystalline oxide layer of the cinvention. However, the Examiner is clearly incorrect.

Specifically, the layers 3, 5 in Wilk do not include a single crystal oxide a cannot be equated with the crystalline oxide layer of the claimed invention. In fa describes these layers having a perovskite crystalline structure, but nowhere does suggest that these layers include a single-crystal oxide (Wilk at col. 3, lines 39-5)

In addition, in complete and fundamental contrast, the oxide material of t invention (e.g., as defined by new dependent claims 71-73) may be very different perovskite oxide, and may crystallize with the bixbyite structure. Such a different since the calcium-containing titanates of Wilk are much more reactive and have properties. The claimed invention may include an inventive oxide material whi different.

Another key difference is that, in contrast to the recitations of new deper 75, Wilk's crystalline oxide cannot be perfectly lattice-matched to silicon. That

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points out Wilk's usage of the phrase "substantially matched" (e.g., see Col. 4, lin

Therefore, Applicant respectfully submits that Wilk does not teach or suggestery element of the claimed invention. Therefore, the Examiner is respectfully rewithdraw this rejection.

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C. The Setsune Reference

The Examiner alleges that Guenzer would have been combined with Setsi claimed invention of claims 17-18 and 57. Applicant submits, however, that thes would not have been combined and even if combined, the combination would no suggest each and every element of the claimed invention.

Setsune discloses a superconductor structure which includes a coating lay mixing either Ba, Sr, Ca, Be, Mg or ZrO₂ with a rare earth element (Setsune at co 57).

However, Applicant submits that these references would not have been calleged by the Examiner. Indeed, these references are directed to different problesolutions.

Specifically, Guenzer is directed to a bismuth titanate (BTO) layer allege template layer for growth of crystallographically-oriented silicon, whereas Setsu a superconductor structure. Therefore, these references are completely <u>unrelate</u> of ordinary skill in the art would have considered combining these disparate refeimpermissible hindsight.

Further, Applicant submits that the Examiner can point to no motivation the references to urge the combination as alleged by the Examiner. In fact, con Examiner's allegations, neither of these references teach or suggest their combine Therefore, Applicant respectfully submits that one of ordinary skill in the art we been so motivated to combine the references as alleged by the Examiner. There

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Examiner has failed to make a prima facie case of obviousness.

However, neither Setsune, nor Guenzer, nor any combination thereof, tead "a crystalline oxide layer comprising single-crystal oxide formed over said substring to claim 15 and similarly recited in claims 21 and 27.

As noted above, unlike conventional semiconductor structures, the claime includes a layer, such as epitaxial silicon, epitaxial germanium, or an amorphous on a crystalline oxide layer which includes single-crystal oxide (Application at pape 9, line 16). This allows the claimed invention to form a structure in which to lattice-matched, substantially defect-free and uniform (Application at page 9, line

Clearly, these novel features are not taught or suggested by Setsune. Inde does the Examiner even allege that this feature is taught or suggested by Setsune

Specifically, Setsune may teach a coating layer (e.g., for a superconducto which includes a rare earth element (Setsune at col. 1, lines 52-57). However, no Setsune teach or suggest that this layer may include single-crystal oxide. Indeed would likely have little benefit to the superconductor structure of Setsune. In she completely unrelated to the claimed invention. Clearly, Setsune does not make a deficiencies of Guenzer.

Applicant notes that mixed oxides with the perovskite structure do not reternary rare earth oxide whose lattice constant can be made to match silicon. Ad feature of the claimed invention (as defined by new dependent claims 74-75) is to material whose lattice constant matches Si. There is absolutely no recognition of Guenzer or Setsune. Thus, in view of the foregoing, claims 17-18 and 57 are put the teachings of Guenzer in view of Setsune et al.

Therefore, Applicant respectfully submits that these references would not combined and even if combined, the combination would not teach or suggest earliement of the claimed invention. Therefore, the Examiner is respectfully requesthis rejection.

D. The Yano Reference

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The Examiner alleges that Guenzer would have been combined with Yan claimed invention of claims 68 and 70. Applicant submits, however, that these r not have been combined and even if combined, the combination would not teach and every element of the claimed invention.

Yano discloses a conductive oxide thin film formed on a substrate having face at its surface. Specifically, Yano teaches that the conductive oxide thin film zirconate with a rare earth component.

However, Applicant submits that these references would not have been calleged by the Examiner. Indeed, these references are directed to different problesolutions.

Specifically, Guenzer is directed to a bismuth titanate (BTO) layer allege template layer for growth of crystallographically-oriented silicon, whereas Yano film structure for forming conductive oxide thin films. Therefore, these reference completely <u>unrelated</u>, and no person of ordinary skill in the art would have consithese disparate references, <u>absent impermissible hindsight</u>.

Further, Applicant submits that the Examiner can point to no motivation the references to urge the combination as alleged by the Examiner. In fact, cont Examiner's allegations, neither of these references teach or suggest their combiner Therefore, Applicant respectfully submits that one of ordinary skill in the art we been so motivated to combine the references as alleged by the Examiner. There Examiner has failed to make a prima facie case of obviousness.

However, neither Yano, nor Guenzer, nor any combination thereof, teach crystalline oxide layer comprising single-crystal oxide formed over said substraction 15 and similarly recited in claims 21 and 27.

As noted above, unlike conventional semiconductor structures, the claim includes a layer, such as epitaxial silicon, epitaxial germanium, or an amorphou on a crystalline oxide layer which includes single-crystal oxide (Application at page 9, line 16). This allows the claimed invention to form a structure in which lattice-matched, substantially defect-free and uniform (Application at page 9, line 16).

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Clearly, these novel features are not taught or suggested by Yano. Indeed attempts to rely on Yano at col. 14, lines 24-30 and col. 15, lines 58-63 to suppor allegations. However, these passages in Yano merely describe a zirconate with a component. This is basically what is known as rare earth stabilized zirconia. It is of compound with a different crystal structure than the oxides that are contempla claimed invention.

Indeed, the oxides in the claimed invention may include <u>pure rare earths</u>. components are rare earth compounds with valence 3 and their bonding to oxyge and their crystal includes a bixbyite crystalline structure. On the other hand, Zr i and since it is the majority component, it dictates the crystal structure and the bor comound that Yano describes.

More specifically, in col. 15, lines 34-45, Yano teaches that the mixed rare crystallizes with a cubic phase. The cubic phase is one of the 7 broad crystal class within that there are several different crystal structures. Zirconia with rare earths Yano) have a fluorite structure, which is one of the cubic crystal classes.

The oxides contemplated by the claimed invention (e.g., which are all rar include the bixbyite structure, which is another of the cubic crystal classes. This is symmetry and different crystallography than the rare earth zirconias (fluorite structure).

Another difference is in the valence and chemical composition. The structure claimed invention has the formula: $(A_xB_{1.x})_2O_3$, so that for every two metal atom oxygen atoms. In the zirconias, on the other hand, the formula is (also according line 53) $Zr_{1.x}R_xO_{2.d}$, where for every metal atom there are only two oxygen atoms mismatch is further taken up by a fraction of oxygen vacancies given by the num chemically, valence and bonding wise, a completely different compound than the invention.

Thus, while both of these materials may indeed be cubic, the cubic class i class (most common materials are all cubic), and if one considers the crystal stru valence/bonding issues, these are very different compounds. As an example, diar both are cubic, but they have different structures within the cubic categorization.

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The Examiner also alleges that Yano teaches a method of forming a lattice structure with a mixed rare earth cubic oxide on silicon. This oxide may be epitax Applicant would point out to the Examiner that Yano does not teach that it is sing film may be epitaxial but it may not necessarily be single crystal but have textured grains. In fact, it is not possible to grow Zr containing rare earth oxides (like Yan epitaxial and single crystal. This is a very important distinction between Yano ar invention.

Thus, Yano does not teach the growth of a single crystal epitaxial structure matched. Instead, Yano only talks about an epitaxial lattice matched structures. important difference. In addition, the crystal structures of Yano's compounds are the claimed invention (this is why Yano does not grow single crystal).

In summary, Yano does not teach forming a <u>mixed rare earth oxide on sil</u> he teaches about <u>growing a zirconate with small rare earth content</u> on silicon (co of Yano, col. 15 lines 58-63, col. 16, lines 45-55). This is an <u>entirely different comixed rare earth oxide</u>. The zirconium oxide is the majority component and the preferably much less (<5 %, Yano col. 16, lines 45-55). Yano deals entirely with which are an completely different class of compounds with a different crystal streath oxides.

In addition, Yano may touch briefly upon growing a rare earth oxide, but growing it on ZrO₂, and not Si (col.17, lines 8-12). Further, Yano nowhere teach epitaxially growing a silicon/oxide/silicon structure. Instead, Yano teaches only BaTiO3/zirconate/Si structures (col. 15, lines 15-20).

Therefore, Applicant respectfully submits that these references would not combined and even if combined, the combination would not teach or suggest ear element of the claimed invention. Therefore, the Examiner is respectfully requesthis rejection.

E. The Ami Reference

The Examiner alleges that Guenzer would have been combined with An

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claimed invention of claims 71 and 73. Applicant submits, however, that these re not have been combined and even if combined, the combination would not teach and every element of the claimed invention.

Ami discloses method of forming a ferroelectric non-volatile memory (Ar However, Applicant submits that these references would not have been coalleged by the Examiner. Indeed, these references are directed to different proble solutions.

Specifically, Guenzer is directed to a bismuth titanate (BTO) layer alleged template layer for growth of crystallographically-oriented silicon, whereas Ami is to a method of forming a ferroelectric non-volatile memory. Therefore, these ref completely <u>unrelated</u>, and no person of ordinary skill in the art would have considered disparate references, <u>absent impermissible hindsight</u>.

Further, Applicant submits that the Examiner can point to no motivation the references to urge the combination as alleged by the Examiner. In fact, cont Examiner's allegations, neither of these references teach or suggest their combin Therefore, Applicant respectfully submits that one of ordinary skill in the art wo been so motivated to combine the references as alleged by the Examiner. Theref Examiner has failed to make a prima facie case of obviousness.

However, neither Ami, nor Guenzer, nor any combination thereof, teache crystalline oxide layer comprising single-crystal oxide formed over said substraclaim 15 and similarly recited in claims 21 and 27.

As noted above, unlike conventional semiconductor structures, the claim provides a structure in which the layers are lattice-matched, substantially defect-(Application at page 9, lines 9-16).

Clearly, these novel features are not taught or suggested by Ami. Indeed the Examiner even allege that this feature is taught or suggested by Ami.

The Examiner attempts to rely on Ami as allegedly teaching an oxide lay bixbyite structure. Applicant notes that Ami may disclose an oxide including a element (e.g., Y₂O₃) which may have a bixbyite structure, nowhere does Ami te

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that the layer includes single crystal oxide. Therefore, Ami does not make up fo deficiencies of Guenzer.

In addition, Applicant would point out that the oxide layer of Ami is come to the claimed invention. Indeed, the layer is formed on silicon oxide (e.g., not a subsrate). Moreover, nowhere does Ami teach or suggest a layer (e.g., silicon, go amorphous layer) formed on the oxide layer.

Therefore, Applicant respectfully submits that these references would no combined and even if combined, the combination would not teach or suggest each element of the claimed invention. Therefore, the Examiner is respectfully reque this rejection.

F. The Reisman Reference

The Examiner alleges that Guenzer would have been combined with Rei claimed invention of claims 21-22, 25-26, 61, 66 and 63-64, and that the Guenze combination would have been further combined with Yano to form the claimed claim 69. Applicant submits, however, that these references would not have been even if combined, the combination would not teach or suggest each and every el claimed invention.

Reisman discloses a method of forming a nonsilicon on insulator structu thin heteroepitaxial layer of nonsilicon semiconductor on a substrate having a la which allegedly matches that of the heteroepitaxial layer (Reisman at Abstract).

However, Applicant submits that these references would not have been alleged by the Examiner. Indeed, these references are directed to different prob solutions.

Specifically, Guenzer is directed to a bismuth titanate (BTO) layer alleg template layer for growth of crystallographically-oriented silicon, whereas Reis directed to forming a nonsilicon on insulator structure. Further, Yano is directe structure for forming conductive oxide thin films and is, therefore, completely unrelated, and

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ordinary skill in the art would have considered combining these disparate referent impermissible hindsight.

Further, Applicant submits that the Examiner can point to no motivation of the references to urge the combination as alleged by the Examiner. In fact, contrexaminer's allegations, neither of these references teach or suggest their combination. Therefore, Applicant respectfully submits that one of ordinary skill in the art wou been so motivated to combine the references as alleged by the Examiner. Therefore Examiner has failed to make a prima facie case of obviousness.

However, neither Reisman, nor Guenzer, nor Yano, nor any combination or suggests "a crystalline oxide layer comprising single-crystal oxide formed ove substrate", as recited in claim 15 and similarly recited in claims 21 and 27.

As noted above, unlike conventional semiconductor structures, the claims provides a structure in which the layers are lattice-matched, substantially defect-1 (Application at page 9, lines 9-16).

Clearly, these novel features are not taught or suggested by Reisman. Ind does the Examiner even allege that this feature is taught or suggested by Reisman

The Examiner attempts to rely on Reisman as allegedly teaching a thin la non-silicon semiconductor formed on a crystalline layer (Figure 1C). However, Reisman teach or suggest that the crystalline layer includes single crystal oxide. oxide layer disclosed by Reisman is a silicon oxide layer 30, which will always a land will never be crystalline. Therefore, Reisman clearly does not make up for to Guenzer, and Yano does not make up for the deficiencies of the Guenzer and combination.

Therefore, Applicant respectfully submits that these references would no combined and even if combined, the combination would not teach or suggest each element of the claimed invention. Therefore, the Examiner is respectfully reque this rejection.

IV. FORMAL MATTERS AND CONCLUSION

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In view of the foregoing, Applicant submits that claims 15-27 and 56-75, presently pending in the application, are patentably distinct over the prior art of recondition for allowance. The Examiner is respectfully requested to pass the above issue at the earliest possible time.

Should the Examiner find the application to be other than in condition for Examiner is requested to contact the undersigned at the local telephone number li discuss any other changes deemed necessary in a <u>telephonic or personal interview</u>

The Commissioner is hereby authorized to charge any deficiency in fees of overpayment in fees to Assignee's Deposit Account No. 50-0510.

Date: 12/4/07

Respectfully Submitted,

Phillip E. Miller, Esq. Reg. No. 46,060

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CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that the foregoing Amendment was filed by facsimile with States Patent and Trademark Office, Examiner Theresa T. Doan, Group Art Unit number (703) 872-9306 this 314 day of Deluber, 2003.

nited at fax

Phillip E. Miller Reg. No. 46,060